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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Karola Richter et al.

Serial No: 10/553,728

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Title: SILICON SUBSTRATE COMPRISING POSITIVE ETCHING  
PROFILES WITH A DEFINED SLOPE ANGLE AND PRODUCTION  
METHOD

Examiner: Patricia Ann George

April 2, 2008

Attorney's Docket No.: HMP201T1

## TRANSMITTAL LETTER

FAX NO. 571 273 1462

Hon. Commissioner of Patents

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Alexandria VA 22313

SIR:


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